

VACUUM PROCESSING APPARATUS

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ABSTRACT OF THE DISCLOSURE

10 The vacuum processing apparatus includes a vacuum  
chamber, a vacuum pump, and a pipe 30 connecting the  
vacuum chamber to the vacuum pump to evacuate the vacuum  
chamber. A flexible pipe is included as a part of the  
pipe, and a mechanism for fixing the flexible pipe so as  
not to shrink at the time of evacuation. The mechanism  
includes a bar for fixing the vacuum pump side of the  
15 flexible pipe to a floor. In an embodiment, the vacuum  
processing apparatus is a substrate bonding apparatus for  
fabricating a display device.